

10/568461

IAP20 REC'D FEB 15 2006

033082M300

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yasuo KOBAYASHI, et al.

International Application No.: PCT/JP2004/011595

International Filing Date: August 12, 2004

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: SEMICONDUCTOR DEVICE, MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE, AND GAS FOR PLASMA CVD PROCESS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists all of the documents noted in the International Search Report (ISR) filed herewith. On the PTO-1449, documents AA and AH are regarded as counterparts, per the ISR. Copies of the cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
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15 FEB 2006

FORM PTO-1449  INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET 033082M300	SERIAL NO. To Be Assigned D1568461
		APPLICANT: Yasuo KOBAYASHI, et al.	
		FILING DATE Herewith	GROUP ART UNIT To Be Assigned

**U.S. PATENT DOCUMENTS**

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	5,989,998	11/23/99	Sugahara, et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

**FOREIGN PATENT DOCUMENTS**

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
	AH	10-284486	10/23/98	Japan			Abstract
	AI	2000-156375	6/6/00	Japan			Abstract
	AJ	WO99/28963	6/10/99	PCT			Abstract
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						

**OTHER INFORMATION** (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
AR	
AS	
EXAMINER:	DATE CONSIDERED:

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.